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Paper No. 5

SCHWEGMAN LUNDBERG WOESSNER & KLUTH P.O. BOX 2938 MINNEAPOLIS, MN 55402

In re Application of

Christopher Pierrat and Nanseng Jeng

Application No. 09/503,553 Filed: February 11, 2000

Attorney Docket No. 303.311US2

For: Method for Optimizing Printing of an

Alternating Phase Shift Mask Having a

Phase Shift Error

: DECISION GRANTING COPY MAILED

: 37 CFR 1.47(a)

SEP 1 9 2000

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The above-identified application was filed on February 11, 2000, without an executed oath or declaration. Accordingly, on April 13, 2000, a "Notice to File Missing Parts of Application" was mailed. In response, on June 2, 2000, a copy of the decision granting a 37 CFR 1.47(a) petition from the parent application (09/031,639) was submitted in compliance with 37 CFR 1.63(d)(3) and MPEP 201.06(c).

For the foregoing reasons, the papers have been reviewed and found in compliance with 37 CFR 1.47(a). This application is hereby accorded Rule 1.47(a) status.

As provided in Rule 1.47(a), this Office will forward notice of this application's filing to the non-signing inventor at the address given in the petition. Notice of the filing of this application will also be published in the Official Gazette.

After this decision is mailed, the above-identified application will be forwarded to Technology Center 1700.

Telephone inquiries should be directed to Petitions Attorney Steven Brantley at (703) 306-5683.

Beverly M. Flanagan

Supervisory Petitions Examiner

Office of Petitions

Office of the Deputy Assistant Commissioner

for Patent Policy and Projects



UNITED STATES DEPARTMENT OF COMMERCE

Patent and Trademark Office ASSISTANT SECRETARY AND COMMISSIONER OF PATENTS AND TRADEMARKS

Washington, D.C. 20231

Paper No. j K

Nanseng Jeng 501 SE - 123rd Avenue Vancouver, WA 98684

In re Application of Christopher Pierrat and Nanseng Jeng Application No. 09/503,553 Filed: February 11, 2000

Attorney Docket No. 303.311US2

Method for Optimizing Printing of an Alternating Phase Shift Mask Having a Phase

Shift Error

DECISION GRANTING STATUS UNDER 37 CFR 1.47(a)

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Dear Mr. Jeng:

You are named as a joint inventor in the above identified United States patent application, filed under the provisions of 35 U.S.C. 116 (United States Code), and 37 CFR 1.47(a), Rules of Practice in Patent Cases. Should a patent be granted on the application you will be designated therein as a joint inventor.

As a named inventor you are entitled to inspect any paper in the file wrapper of the application, order copies of all or any part thereof (at a prepaid cost per 37 CFR 1.19) or make your position of record in the application. Alternatively, you may arrange to do any of the preceding through a registered patent attorney or agent presenting written authorization from you. If you care to join the application, counsel of record (see below) would presumably assist you. Joining in the application would entail the filing of an appropriate oath or declaration by you pursuant to 37 CFR 1.63.

Requests for information regarding your application should be directed to the File Information Unit at (703)308-2733. Information regarding how to pay for and order a copy of the application, or a specific paper in the application, should be directed to Certification Division at (703)308-9726 or 1(800)972-6382 (outside the Washington D.C. area).

Telephone inquiries regarding this communication should be directed to Petitions Attorney Steven Brantley at (703) 306-5683.

Beverly M. Flanagan

Supervisory Petitions Examiner

Office of Petitions

cc:

Office of the Deputy Assistant Commissioner

for Patent Policy and Projects

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